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(Substitute for form 1449/PTO)

 ATTY. DOCKET NO.
050024-0015

 SERIAL NO.
10/635,777

 APPLICANT
Akiyoshi MIKAMI

 FILING DATE
August 07, 2003

 GROUP
1794

U.S. PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		US			
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FOREIGN PATENT DOCUMENTS

EXAMINER'S INITIALS	CITE NO.	Foreign Patent Document Country Codes-Number 4-Kind Codes (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines Where Relevant Figures Appear	Translation Yes No

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER'S INITIALS	CITE NO.	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.
/CT/		MIKAMI et al "Chemical Vapor Deposition of ZnS: Mn Electroluminescent Films in a Low-Pressure Halogen Transport System" Journal of Chrystal Growth 110 (1991) pages 381-394 Elsevier Science Publishers B.V. North Holland

 EXAMINER
 /Camie Thompson/

 DATE CONSIDERED
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1 Applicant's unique citation designation number (optional). 2 Applicant is to place a check mark here if English language Translation is attached.